

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Heidi Cao et al. Art Unit: 1752
Serial No.: 10/686,031 Examiner: Amanda C. Walke
Filed: October 14, 2003 Assignee: Intel Corporation
Title: PHOTORESISTS WITH REDUCED OUTGASSING FOR EXTREME
ULTRAVIOLET LITHOGRAPHY

MAIL STOP AF

Commissioner For Patents
P.O. Box 1450
Alexandria, Va 22313-1450

AMENDMENT

In response to the Office action mailed August 10, 2006,
please reconsider this application in light of the following:

Amendments to the Claims in the **Listing of Claims** beginning on
page 2; and

Remarks beginning on page 11.

*Do Not Enter
ACW 11/16/06*